



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1430  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8920

SERIAL NUMBER 10/773,333	FILING DATE 02/09/2004 RULE	CLASS 257	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. Q77321
-----------------------------	-----------------------------------	--------------	------------------------	----------------------------------

## APPLICANTS

Hiroshi Okumura, Tokyo, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\*

none. *st*

03/06/05

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

in file - *st* .. 03/06/05

JAPAN 042083/2003 02/20/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/06/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after <i>Advanc</i>	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	<i>st</i> Examiner's Signature <i>st</i> Initials	JAPAN	8	28	3

## ADDRESS

23373  
 SUGHRUE MION, PLLC  
 2100 PENNSYLVANIA AVENUE, N.W.  
 SUITE 800  
 WASHINGTON , DC  
 20037

## TITLE

Thin film transistor substrate and method for manufacturing the same

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
RECEIVED 914		